



#12/A
6-02
Mellish
PATENT

Customer No. 22,852
Attorney Docket No. 08038.0024

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Noriaki FUKIAGE) Group Art Unit: 2811
Serial No.: 09/657,055) Examiner: H. Vu
Filed: September 7, 2000)
For: SEMICONDUCTOR DEVICE AND)
METHOD OF MAKING THE SAME)

Assistant Commissioner for Patents
Washington, DC 20231

Sir:

AMENDMENT

In reply to the Office Action dated January 15, 2002, the period for reply having been extended for two months by a request for extension and fee payment filed concurrently herewith, please amend the application as follows:

IN THE TITLE:

Please change the title to read --SEMICONDUCTOR DEVICE HAVING MULTILAYER INTERCONNECTION STRUCTURE AND METHOD OF MAKING THE SAME--.

IN THE SPECIFICATION:

Please amend the paragraph beginning at line 11 of page 1 and ending at line 17 of page 1 as follows:

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